

COURSE: MICROSYSTEMS AND NANOELECTRONICS					
MASTER: ELECTRONIC SYSTEMS ENGINEERING AND APPLICATIONS	YEAR: 2015-16	TERM: 2nd			

	WEEKLY PLANNING								
WEEK	SESSION	DESCRIPTION	GROUPS (mark X)		Special room for session (computer classroom,	WEEKLY PROGRAMMING FOR STUDENT			
			LECTURES	SEMINARS/ LAB ¹	audio-visual classroom)	DESCRIPTION	CLASS HOURS	HOMEWORK HOURS (Max. 7h week)	
1	1	Introduction to Electronic Microsystems Fabrication	х			Previous reading. Answering questions about background.	1,5	4	
1	2	Microsystems Design Fundamentals. Examples.	х			Previous reading. Revision of Class Materials.	1,5	4	
2	3	Optical MEMs: Introduction, chronology, classification. Micromirrors technology. Scanning applications.	х			Previous reading. Revision of Class Materials.	1,5	7	
2	4	Optical MEMs for displays and optical Communication.	х			Previous reading. Revision of Class Materials.	1,5		
3	5	Microsystems: Discussion of Case Studies		х		The students, split in groups, will prepare the description of a case study that will be discussed in class	1,5		
3	6	Introduction to Nanoelectronics and Fundamental	х			Previous reading. Revision of Class Materials.	1,5		

		Total	Total 2 (Hours of class plus student homework hours at week 8)				20	
			•		Subtotal 2	3	17	
3		Assessment				3	7	
L-7		Tutorials, handing in, etc				10	10	
		Total	1 (Hours of class p	lus student ho	mework hours between weeks 1-7)	55		
		¹ A maximum of 1-2 lab sessions			Subtotal 1	21	34	
7	14	Quantum Computing		х	Previous reading. Revision of Class Materials.	1,5	3	
1	13	Molecular Electronics and Metatronics	х		Previous reading. Revision of Class Materials.	1,5	5	
i	12	Nanoelectronics: Discussion of Case Studies	x		The students, split in groups, will prepare the description of a case study that will be discussed in class	1,5		
;	11	Nanoelectronic Sensors and Sensors arrays	х		Previous reading. Revision of Class Materials.	1,5		
5	10	Nanoelectronic Logic Devices	x		Previous reading. Revision of Class Materials.	1,5		
;	9	Technological Aspects: New materials and Components (CNT, Graphene,)	x		Previous reading. Revision of Class Materials.	1,5		
	8	Technological Aspects: Fabrication	x		Previous reading. Revision of Class Materials.	1,5		
	7	Fundamentals of Nanoelectronics: Electronic Properties and Quantum Effects	х		Previous reading. Revision of Class Materials.	1,5		

TOTAL (Total 1	+ Total 2)	75	
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